04-13-2006

U.S. DEPARTMENT OF COMMERCE nited States Patent and Trademark Office

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REC 10204.0700						
103218780						
To the Director of the U.S. Patent and Trademark Office: Please record the attached documents or the new address(es) below.  Name of conveying party(ies)/Execution Date(s):  2. Name and address of receiving party(ies)						
1. Name of conveying party(ies)/Execution Date(s):	Name: SUMCO CORPORATION					
Sakae Koyata     Yuichi Kakizono	Internal Address:					
Tomohiro Hashii     Katsuhiko Murayama						
	10 5					
Execution Date(s) <u>January 25, 2006</u> Additional name(s) of conveying party(ies) attached? Yes No	Street Address: 2-1, Shibaura 1-chome					
3. Nature of conveyance:						
Assignment Merger	City: Minato-Ku					
T C C	•					
Security Agreement	State: Tokyo					
Government Interest Assignment Executive Order 9424, Confirmatory License	Country: Japan Zip:					
	Additional name(s) & address(es) attached? ☐ Yes ✓ No					
4. Application or patent number(s):	document is being filed together with a new application.					
A. Patent Application No.(s)	B. Patent No.(s)					
11/345,009						
	tached? Yes ✓No					
	6. Total number of applications and patents					
5. Name and address to whom correspondence concerning document should be mailed:	involved:					
Name: Jules E. Goldberg, Esq.	7. Total fee (37 CFR 1.21(h) & 3.41) \$ 40.00					
Internal Address: Reed Smith LLP	Authorized to be charged by credit card					
internal y to a reconstruction of the recons	Authorized to be charged to deposit account					
Street Address: 599 Lexington Avenue, 29th FI	✓ Enclosed					
Officer / Idd 1000. doi: 1000	None required (government interest not affecting title)					
City: New York	8. Payment Information					
7: 10000	a. Credit Card Last 4 Numbers					
	Expiration Date					
Phone Number: (212) 521-5403	b. Deposit Account Number 50-1529					
Fax Number: (212) 521-5450	Authorized User Name					
Email Address: jgoldberg@reedsmith.com						
9. Signature:	April 6, 2006  Date					
Julios E. Goldberg, Esq.	Total number of pages including cover 5					
Jules E. Goldberg, Esq.  Name of Person Signing  sheet, attachments, and documents:						
Documents to be recorded (including cover sheet) should be faxed to (703) 306-5995, or mailed to:						

Mail Stop Assignment Recordation Services, Director of the USPTO, P.O.Box 1450, Alexandria, V.A. 22313-1450

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DENCENSOR BRANKE J- -0-8081

Whereas, I/We, Sakae	Koyata	
of c/o SUMCO CORPORATION	N, 2-1, Shibaura 1-chome, M	linato-ku, Tokyo Japan
(hereafter "Assignor") have new a	nd useful improvements in ETCHING	LIQUID FOR CONTROLLING SILICON
		ING SILICON WAFER USING THE SAME
······································	nt in the United States of America     is	
And Whereas, SUMCO	CORPORATION	
of 2-1, Shibaura 1-chome	e, Minato-ku, Tokyo Japan	
		d in the Letters Patent to be obtained therefor:
sufficiency of which is hereby ack		good and valuable consideration (the transferred and set over, and by these presents of the United States of America, the full and
		vention embodied therein, as fully set forth and
described in the specification.	in and to the said application and the in-	vention embodied therein, as fully set forth and
<del></del>	i on	
		0
		ion, continuation, substitute or renewal
Assignor had this assignment and	transfer not been made. es and requests the Commissioner of Pa	ely as the same would have been held by the stents and Trademarks to issue any and all such
In testimony whereof, the	Assignor has hereunto set his hand this	s day of
WITNESS:	INVENTOR(S):	
	Sakae Koyata	, Sakae Koyata.
	(Name of Assignor)	(Signature of Assignor)
	(Name of Assignor)	(Signature of Assignor)
	, <b>,</b>	/
	(Name of Assignor)	(Signature of Assignor)
	(Name of Assignor)	(Signature of Assignor)
	()	( Carpinose of Ar. 4 most Charlet)
	(Name of Assignor)	(Signature of Assignor)

#### ReedSmithur

375 Park Avenue 17th Floor New York, NY 10152-1799 212.521.5400 Fax 212.521.5450

Whereas, I/We, Yuich	i Kaizono	
of c/o SUMCO CORPORATION	, 2-1, Shibaura 1-chome, Mir	nato-ku, Tokyo Japan
		JOUID FOR CONTROLLING SILICON IG SILICON WAFER USING THE SAME
which application for Letters Patent	in the United States of America     is a	about to be filed.   has been filed.
And Whereas, SUMCO	CORPORATION	
of 2-1, Shibaura 1-chome	, Minato-ku, Tokyo Japan	
hereinafter "Assignee") is/are desir	rous of acquiring an interest therein and	in the Letters Patent to be obtained therefor:
Now, therefore, be it know	n by all whom it may concern, that for g	good and valuable consideration (the
sufficiency of which is hereby acknowledge	owledged) the Assignor has assigned, tra	ansferred and set over, and by these presents
loes assign, transfer and set over u	ato the said Assignee for the territory of	the United States of America, the full and
exclusive right, title, and interest in	and to the said application and the inve	ntion embodied therein, as fully set forth and
described in the specification.		
A. prepared and executed	on	
	and Trademark Office under Serial No.	
	including any division	
Assignor had this assignment and t Assignor hereby authorize	ransfer not been made. s and requests the Commissioner of Pate	y as the same would have been held by the
Letters Patent for said invention to	said Assignee.	
In testimony whereof, the	Assignor has hereunto set his hand this	25 day of
WITNESS:	INVENTOR(S):	
	Yuichi Kakizono	, Thurchi Hakyono
	(Name of Assignor)	(Signature of Assignor)
	(Name of Assignor)	(Signature of Assignor)
	(Name of Assignor)	(Signature of Assignor)
	(Name of Assignor)	(Signature of Assignor)
	(Name of Assignor)	/ (Signature of Assignor)
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### ReedSmithup

375 Park Avenue 17th Floor New York, NY 10152-1799 212.521.5400 Fax 212.521.5450

Whereas, I/We, Tomohir	ro Hashii	
of c/o SUMCO CORPORATION,	2-1, Shibaura 1-chome, M.	inato-ku, Tokyo Japan
(hereafter "Assignor") have new and u WAFER SURFACE SHAPE At	useful improvements in ETCHING ND METHOD FOR MANUFACTURI	LIQUID FOR CONTROLLING SILICON NG SILICON WAFER USING THE SAME
which application for Letters Patent in	n the United States of America     is	about to be filed.   has been filed.
And Whereas, SUMCO CO	ORPORATION	
of 2-1, Shibaura 1-chome,	Minato-ku, Tokyo Japan	
(hereinafter "Assignee") is/are desiron	us of acquiring an interest therein and	d in the Letters Patent to be obtained therefor:
•		good and valuable consideration (the
-		ransferred and set over, and by these presents
		f the United States of America, the full and
<del>-</del> '	nd to the said application and the inv	vention embodied therein, as fully set forth and
described in the specification.	_	
	nd Trademark Office under Serial Ne	D
		ion, continuation, substitute or renewal
		eld and enjoyed by the said Assignee to the full
		ely as the same would have been held by the
Assignor had this assignment and tra		
Assignor hereby authorizes	and requests the Commissioner of Pa	stents and Trademarks to issue any and all such
Letters Patent for said invention to sa	_	
		o (t
In testimony whereof the A	ssignor has hereunto set his hand thi	s day of
WITNESS:	INVENTOR(S):	,
	Tomohiro Hashii	Touch to Mashin
	(Name of Assignor)	(Signature of Assignor)
	(Name of Assignor)	(Signature of Assignor)
	(Name of Assignor)	(Signature of Assignor)
		1
	(Name of Assignor)	(Signature of Assignor)
	(Name of Assignor)	(Signature of Assignor)

# ReedSmith

375 Park Avenue 17th Floor New York, NY 10152-1799 212.521.5400 Fax 212.521.5450

Whereas, I/We, Katsuhi	ko Murayama	
of c/o SUMCO CORPORATION,	2-1, Shibaura 1-chome, Mir	nato-ku, Tokyo Japan
(hereafter "Assignor") have new and u	useful improvements in ETCHING L. ND METHOD FOR MANUFACTURING	IQUID FOR CONTROLLING SILICON G SILICON WAFER USING THE SAME
which application for Letters Patent is	n the United States of America     is a	bout to be filed. has been filed.
And Whereas, SUMCO CO	ORPORATION	
of 2-1, Shibaura 1-chome,	Minato-ku, Tokyo Japan	
(hereinafter "Assignee") is/are desirou	as of acquiring an interest therein and i	in the Letters Patent to be obtained therefor
	by all whom it may concern, that for go	1
•	- ·	nsferred and set over, and by these presents
<u> </u>	- · · · · · · · · · · · · · · · · · · ·	he United States of America, the full and
described in the specification.	nd to the said application and the inver	ntion embodied therein, as fully set forth and
A. prepared and executed or		
· =	nd Trademark Office under Serial No.	<u> </u>
on		n, continuation, substitute or renewal
		and enjoyed by the said Assignee to the full
• =	<del>-</del> -	as the same would have been held by the
Assignor had this assignment and tra		1
		ì
Assignor hereby authorizes a	and requests the Commissioner of Pater	nts and Trademarks to issue any and all such
Letters Patent for said invention to sa	id Assignee.	
		- £-
	ssignor has hereunto set his hand this _	2 day of
<u>Jan</u> 20 06		
WITTIESS.	TNIT TENETOD (S)-	
WITNESS:	INVENTOR(S):	
	Katsuhiko Murayama	1 Cotsulika Muraxama
	(Name of Assignor)	(Signature of Assignor)
	(Name of Assignor)	(Signature of Assignor)
		(Digitality of English)
	(A)	(6)
	(Name of Assignor)	(Signature of Assignor)
		/
	(Name of Assignor)	(Signature of Assignor)
		/
	(Name of Assignor)	(Signature of Assignor)

ReedSmith

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> PATENT REEL: 017772 FRAME: 0379

RECORDED: 04/11/2006